

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Isamu Kobori et al.	Art Unit	: 2812
Serial No.	: 10/623,581	Examiner	: Stanetta Isaac
Filed	: July 22, 2003	Conf. No.	: 6534
Title	: METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM TRANSISTOR		

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF SEPTEMBER 13, 2007

Please amend the above-identified application as follows:

Amendments to the Claims begins on page 2 of this paper.

Arguments/Remarks begins on page 10 of this paper.